N Channel MOSFET BSIM3SOI model mosnbsim3soi

Figure 1: N Channel MOSFET BSIM3SOI model

Form: mosnbsim3soi5T1: $\langle instance\ name \rangle\ n_1\ n_2\ n_3\ n_4\ n_5\ \langle parameter\ list \rangle$

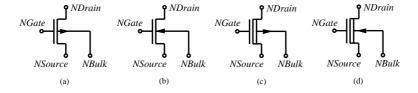
 n_1 is the drain node,

 n_2 is the gate node,

 n_3 is the source node,

 n_4 is the substrate node,

 n_5 is the bulk node.



Model Parameters:

Parameter	Description	Default	Units
1	Length	5.0e-06	m
w	Width	5e-06	m
tsi	Silicon film thickness	1e-07	m
tbox	Buried oxide thickness	3.0e-07	m
tox	Gate oxide thickness	1e-08	m
toxqm	Effective oxide thickness		
	considering quantum effect	tox	m
xj	S/D junction depth	tsi	m
nch	Channel doping concentration	$1.7\mathrm{e}17$	$1/cm^{-3}$
nsub	Substrate doping concentation	6e16	$1/cm^{-3}$
ngate	Poly-gate doping concentation	0.0	$1/cm^{-3}$
vth0	Threshold voltage @Vbs=0 for		·
	long and wide device	0.7	V
k1	First order body effect coefficient	0.6	$V^{0}.5$
k1w1	First body effect width dependent parameter	0.0	m
k2	Second order body effect coefficient	0.0	-
k3	Narrow width effect coefficient	0.0	-
k3b	Body effect coefficient of k3	0.0	1/V
kb1	Backgate body charge coefficient	1.0	-
wO	Narrow width effect parameter	0.0	m
nlx	Lateral non-uniform doping parameter	1.74e-07	m
dvt0	First coefficient of short-channel		
	effect on Vth	2.2	-
dvt1	Second coefficient of short-channel		
	effect on Vth	0.53	-
dvt2	Body-bias coefficient of		
	short-channel effect on Vth	-0.032	1/V
dvt0w	First coefficient of narrow width		
	effect on Vth for small channel length	0.0	-
dvt1w	Second coefficient of narrow width		
	effect on Vth for small channel length	5.3e6	-
dvt2w	Body-bias coefficient of narrow width		
	effect on Vth for small channel length	-0.032	1/V
u0	Mobility at Temp=Tnom	0.067	$cm^2/V-sec$
ua	First-order mobility degradation coefficient	2.25e-09	m/V

Table 1: MOS Model Parameter table 1

Parameter	Description	Default	Units
ub	Second-order mobility degradation coefficient	5.9e-19	m/V^2
uc	Body-effect of mobility degradation coefficient	-0.0465	1/V
vsat	Saturation velocity at Temp=Tnom	8e4	m/sec
a0	Bulk charge effect coefficient		
	for channel length	1.0	-
ags	Gate bias coefficient of Abulk	0.0	1/V
ъ0	Bulk charge effect coefficient for		
	channel width	0.0	m
b1	Bulk charge effect width offset	0.0	m
keta	Body-bias coefficient of bulk		
	charge effect	0.0	1/V
ketas	Surface potential adjustment for		
	bulk charge effect	0.0	V
a1	First non-saturation effect parameter	0.0	1/V
a2	Second non-saturation effect parameter	1.0	-
rdsw	Parasitic resistance per unit width	100	ohm-um
prwb	Body effect coefficient of rdsw	0.0	1/V
prwg	Gate-bias effect coefficient of rdsw	0.0	-
wr	Width offset from Weff for		
	Rds calculation	1.0	-
nfactor	Subthreshold swing factor	1.0	-
wint	Width offset fitting parameter		
	from I-V without bias	0.0	$\mid m \mid$
lint	Length offset fitting parameter		
	from I-V without bias	0.0	$\mid m \mid$
dwg	Coefficient of Weff's gate dependence	0.0	m/V
dwb	Coefficient of Weff's substrate		
	body bias dependence	0.0	$(m/V)^0.5$
dwbc	Width offset for body contact isolation edge	0.0	$\mid m \mid$
voff	Offset voltage in the threshold region		
	for large W and L	-0.08	$\mid V \mid$
eta0	DIBL coefficient subthreshold region	0.08	_
etab	Body bias coefficient for the		
	subthreshold DIBL effect	-0.07	1/V
dsub	DIBL coefficient in the subthreshold region	0.56	-
cit	Interface trap capacitance	0.0	F/m^2
cdsc	Drain/Source to channel coupling capacitance	2.4e-04	F/m^2

Table 2: MOS Model Parameter table 2

Parameter Des	scription	Default	Units
cdscb Bod	ly-bias sensitivity of cdsc	0.0	F/m^2
cdscd Dra	in-bias sensitivity of cdsc	0.0	F/m^2
pclm Cha	annel length modulation parameter	1.3	-
pdibl1 Firs	st output resistance DIBL		
effec	ct correction parameter	0.39	-
pdibl2 Seco	ond output resistance DIBL		
effec	ct correction parameter	0.0086	-
pvag Gat	e dependence of Early voltage	0.0	-
delta Effe	ective Vds parameter	0.01	-
alpha0 The	e first parameter of impact		
ioni	zation current	0.0	m/V
beta0 Firs	st Vds dependent parameter of		,
imp	eact ionization current	0.0	1/V
beta1 Seco	ond Vds dependent parameter of		,
imp	eact ionization current	0.0	-
beta2 This	rd Vds dependent parameter of		
imp	act ionization current	0.1	V
	ninal drain saturation voltage at		
thre	eshold for impact ionization current	0.9	V
	e substrate overlap capacitance		
	unit channel length	0.0	F/m
cjswg Sou	rce/Drain (gate side) sidewall junction		,
	acitance per unit width		
	rmalized to 100nm tsi)	1e-10	F/m^2
1 '	rce/Drain (gate side) sidewall junction		,
1 1	acitance built in potential	0.7	V
1 -	rce/Drain (gate side) sidewall junction		
1 5 5	acitance grading coefficient	0.5	V
tt Diff	fusion capacitance transit time coefficient	1.0e-12	sec
csdesw S/D	o sidewall fringing capacitance per unit length	0.0	F/m
cgs1 Ligh	ht doped source-gate region overlap capacitance	0.0	F/m
	ht doped drain-gate region overlap capacitance	0.0	F/m
1 -	efficient for lightly doped region overlap		,
	acitance fringing field capacitance	0.6	F/m
1 -	stant term for the short channel model	0.1e-07	$m^{'}$
	ponential term for the short channel model	0.0	-
1 -	gth offset fitting parameter for gate charge	lint	m
	gth offset fitting parameter for body charge	0.0	m
	gth offset fitting parameter for backgate charge	0.0	m
	lth offset fitting parameter from C-V	wint	m

Table 3: MOS Model Parameter table 3

Parameter	Description	Default	Units
delvt	Threshold voltage adjust for C-V	0.0	V
fbody	Scaling factor for body charge	1.0	-
moin	Coefficient for the gate-bias dependent		
	surface potential	15.0	$V^{0.5}$
tnom	Parameter measurement temperature	300.15	K
ute	Temperature coefficient of mobility	-1.5	-
kt1	Temperature coefficient of Vth	-0.11	-
kt1l	Channel length dependence of the		
	temperature coefficient of Vth	0.0	V*m
kt2	Body-bias coefficient of the Vth temperature effect	0.022	-
ua1	Temperature coefficient for ua	4.31e-09	m/V
ub1	Temperature coefficient for ub	-7.61e-18	$(m/V)^2$
uc1	Temperature coefficient for uc	-0.056	1/V
at	Temperature coefficient of vsat	3.3e4	m/sec
prt	Temperature coefficient of rdsw	0.0	ohm - um
vbm	Maximum body voltage	-3.0	-
xt1	Doping depth	1.55e-07	-
pdiblb	Body-effect on drain induced barrier lowering	0.0	-
11	Length reduction parameter	0.0	m
llc	Length reduction parameter	0.0	m
lln	Length reduction parameter	1.0	m
lw	Length reduction parameter	0.0	m
lwc	Length reduction parameter	0.0	m
lwn	Length reduction parameter	0.0	m
lwl	Length reduction parameter	0.0	m
lwlc	Length reduction parameter	0.0	m
wl	Width reduction parameter	0.0	m
wlc	Width reduction parameter	0.0	m
wln	Width reduction parameter	1.0	m
ww	Width reduction parameter	0.0	m
WWC	Width reduction parameter	0.0	m
wwn	Width reduction parameter	1.0	m
wwl	Width reduction parameter	0.0	m
wwlc	Width reduction parameter	0.0	m
temp	Circuit temperature	300.15	K
acde	Exponential coefficient for charge	1.0	m/V

Table 4: MOS Model Parameter table 4

Notes:

There is no equivalent SPICE element. $\,$

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